Thermoelectric properties and microstructure of c-axis-oriented Ca$_3$Co$_4$O$_9$ thin films on glass substrates

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$c$-axis-oriented Ca$_3$Co$_4$O$_9$ thin films have been grown directly on glass (fused silica) substrate by pulsed laser deposition. Detailed microstructure analysis showed stacking faults abundant throughout the films. However, the Seebeck coefficient ($\sim$130 $\mu$V/K) and resistivity ($\sim$4.3 m$\Omega$ cm) of these films on glass substrate at room temperature were found comparable to those of the single-crystal samples. The presence of these structural defects could reduce thermal conductivity, and thus enhance the overall performance of cobaltate films to be potentially used in the thermoelectric devices. © 2005 American Institute of Physics. [DOI: 10.1063/1.2117615]

Recently, layered cobaltates have emerged as promising thermoelectric (TE) materials due to their excellent TE properties. Calcium cobaltate is among the best thermoelectric oxides, and thus has been extensively studied in single-crystal form. 1-6 The studies of TE properties and microstructure of cobaltate films are somewhat limited. 7-10 In many TE applications, such as thermochromy on a chip, biothermoelectric chip, and active cooling for microelectronic processor, film devices are required that allow localizing cooling/heating at points of interest. High-quality TE thin films, having the crystal structure of single crystals, can have a low resistivity and a high Seebeck coefficient intrinsic to their electronic band structures. At the same time, thin films are expected to have thermal conductivity lower than that of the single crystals due to strong phonon scatterings at both surfaces and film/substrate interfaces. 11,12 Hence, high-quality films could result in higher value of ZT. ZT is the figure of merit that measures the performance of a TE material, and is defined as $ZT=S^2T/(\rho\kappa)$, where $T$, $S$, $\rho$, and $\kappa$ are the absolute temperature, Seebeck coefficient, electrical resistivity, and thermal conductivity, respectively.

We have recently reported growth of high-quality $c$-axis-oriented Ca$_3$Co$_4$O$_9$ thin films directly on Si (100) wafers by pulsed laser deposition (PLD). 13 Cross-sectional transmission electron microscopy (TEM) characterization revealed that the Ca$_3$Co$_4$O$_9$ film on a Si (100) substrate had a nearly perfect crystalline structure. The Seebeck coefficient and resistivity of the Ca$_3$Co$_4$O$_9$ thin films are 126 $\mu$V/K and 4.3 m$\Omega$ cm, respectively, at room temperature, comparable to those of the single-crystal samples. Thus, reducing the thermal conductivity seems to be an effective way to further enhance the TE performance of Ca$_3$Co$_4$O$_9$ films.

It is well known that suitable structural defects, such as stacking faults and grain boundaries, will create additional scattering mechanisms in the material and reduce the thermal conductivity. This effect has been observed in both bulk and thin-film superlattice samples. 14,15 However, the introduction of defects may also decrease the Seebeck coefficient and electrical conductivity. The ultimate goal is to engineer the structural defects in the films that block the phonon transport but not the charge carriers. Recently, we have prepared Ca$_3$Co$_4$O$_9$ films on various single crystalline, polycrystalline, and amorphous substrates under different conditions. In this letter, we report that the Ca$_3$Co$_4$O$_9$ films grown on a glass substrate (fused silica or amorphous SiO$_2$) have those desirable structural defects that may result in lower thermal conductivity. Remarkably, the Seebeck coefficient ($\sim$130 $\mu$V/K) and resistivity ($\sim$4.3 m$\Omega$ cm) at room temperature are still comparable to those of the best single-crystal samples.

Our Ca$_3$Co$_4$O$_9$ thin films were grown in situ by the PLD process. A commercial glass (fused silica) wafer (from Sydor Optics, Inc.) was used as the substrate. The substrates were cleaned in acetone and methanol prior to the deposition. Films about 1600 Å thick were deposited at a substrate temperature of 700 °C with a laser energy density of $\sim$1.5 J/cm$^2$, under an oxygen pressure of 300 mTorr. After deposition, the films were cooled to room temperature in $\sim$1 atm of oxygen. Figure 1 shows the x-ray diffraction (XRD) patterns for the Ca$_3$Co$_4$O$_9$ film grown on the glass substrate. The XRD patterns exhibit nearly perfect $c$-axis alignment for the thin film. (Note: The log scale used for the intensity counts.) No diffraction peaks due to impurity phases were observed.

A cross-sectional TEM overview image of the Ca$_3$Co$_4$O$_9$/glass interface region is shown in Fig. 2. Two interfaces can be seen in Fig. 2, indicated by Arrows 1 and 2. Between the crystalline Ca$_3$Co$_4$O$_9$ film and glass substrate, there is an amorphous layer $\sim$10 nm thick, whose composition is related to that of Ca$_3$Co$_4$O$_9$. This is very similar to the Ca$_3$Co$_4$O$_9$ film grown on the Si(100) substrate, the native oxide of which was not removed prior to deposition, where...
the growth also starts amorphous before it turns to small grain crystalline and excellent quality crystalline throughout the film.\textsuperscript{13}

High-resolution electron microscopy (HREM) images of the layered Ca$_3$Co$_4$O$_9$ film near the interface are shown in Fig. 3. Figure 3(a) shows well-ordered layer structures of Ca$_3$Co$_4$O$_9$ stacked along the $c$ axis. These structures were observed near the interface and everywhere inside the Ca$_3$Co$_4$O$_9$ films. The structural defects in the films are mostly stacking faults, abundant throughout the films at various length scales. Sometimes, long stacking faults could be found across the entire TEM specimen. Nanosized second-phase materials (typically 5–10 nm) were also observed in certain regions close to the interface, but hardly present in the interior of the film. In Fig. 3(b)—showing a TEM image taken near the interface—Arrow 1 indicates a stacking fault that alters the periodic sequence of layers. Arrow 2 indicates a second phase, with a period of the layers that differs from the main phase of the film, possibly due to different composition ratios of Ca/Co. This was also observed by Yoshida et al.\textsuperscript{7} in the Ca$_3$Co$_4$O$_9$ film grown on SrTiO$_3$(100) substrate.

Figure 4 shows the temperature dependence of the resistivity $\rho$ and Seebeck coefficient $S$ for a Ca$_3$Co$_4$O$_9$ film grown on glass substrate, together with the data of a Ca$_3$Co$_4$O$_9$ film grown on Si (100) substrate. The $\rho$-$T$ curve of the film on glass exhibits very weak metallic behavior at $T>170$ K, and shows a broad minimum with decreasing temperature. At low temperatures, the $\rho$-$T$ curve exhibits a diverging behavior due to the magnetic phase transition of cobaltates. This temperature dependence is similar to that for the Ca$_3$Co$_4$O$_9$ single-crystal in-plane resistivity $\rho_{ab}(T)$ (Ref. 5) and the film on Si (100) substrate. However, the slope of the $\rho$-$T$ curve at the high-temperature region for films on Si (100) and single crystals are much steeper than the present films on glass, as is clearly shown in the inset to Fig. 4(a). The Ca$_3$Co$_4$O$_9$ film grown on the Si (100) substrate has almost perfect crystallinity and its $\rho$-$T$ curve is close to that of the single-crystal samples.\textsuperscript{13} The Ca$_3$Co$_4$O$_9$ film grown on a glass substrate has a significant amount of stacking faults. It is not surprising that these defects cause additional carrier scattering, which changes the overall $\rho$-$T$ behavior. This effect appears to be more pronounced at low temperature, but much less at a high temperature. At $T>300$ K, the difference in the resistivity of films on glass and single-crystalline substrates are, in fact, very small. The mechanism for this is certainly worthy of further investigation, but is beyond the scope of this letter.

The Seebeck coefficient of the Ca$_3$Co$_4$O$_9$ films was measured using a four-terminal steady-state method in a Quantum Design PPMS system. Figure 4(b) shows the Seebeck coefficient $S$ and the temperature dependence of the Seebeck coefficient $S(T)$ for Ca$_3$Co$_4$O$_9$ films on glass substrate (closed circle) and Si (100) substrate (open circle). An expanded view of (a) is shown as an inset.
coefficient $S$ as a function of temperature for a Ca$_3$Co$_4$O$_9$ film on a glass substrate between 50 K and 400 K. $S$ monotonically increases with temperature. At 300 K, the thermoelectric power for the Ca$_3$Co$_4$O$_9$ film on glass is around 130 $\mu$V/K; very close to that of the single crystal sample\textsuperscript{6} and that of the film grown on Si (100) substrate.

Though there is no reliable method of directly measuring the in-plane thermal conductivity ($\kappa$) of thin films of a few hundred nm thickness, we expect that the Ca$_3$Co$_4$O$_9$ film on a glass substrate would have a substantially lower $\kappa$ than that of the single-crystal samples. This is due to the strong phonon scattering at stacking faults, in addition to the scattering at film surfaces and film/substrate interfaces. Therefore, the $ZT$ values of these films are expected to be better than the single-crystal samples. Furthermore, the glass substrate is an amorphous material and has very low thermal conductivity. Thus, cobaltate films on glass substrates will have additional advantages in practical TE device applications.

In summary, we demonstrate that $c$-axis-oriented thin films of Ca$_3$Co$_4$O$_9$ can be grown directly on a glass substrate by PLD. Detailed microstructural analysis revealed good overall $c$-axis alignment of the Ca$_3$Co$_4$O$_9$ film, with a high density of stacking faults throughout the films. The measured resistivity and Seebeck coefficient at temperatures above 300 K are similar to that found in the single-crystal samples. Devices utilizing Ca$_3$Co$_4$O$_9$ on amorphous SiO$_2$ should have enhanced thermoelectric performance due to a reduced overall thermal conductivity, caused by the stacking faults in the films and by the intrinsically low substrate thermal conductivity.

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